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# **INFORMATION DISCLOSURE STATEMENT BY APPLICANT**

Applicant: Heine M. MULDER *et al.*

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Page

1

of

1

Examiner: Unknown

Group Art Unit: Unknown

## **U.S. PATENT DOCUMENTS**

Examiner's Initials*		Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
	AR						
	BR						
	CR						
	DR						
	ER						
	FR						
	GR						
	HR						
	IR						
	JR						
	KR						
	LR						
	MR						
	NR						

## **FOREIGN PATENT DOCUMENTS**

OVERVIEW OF DOCUMENTS							Abstract		Readily Available	
		Document Number	Date MM/YYYY	Country	Inventor Name		Enclosed	No	Enclose	No
	OR									
	PR									
	QR									
	RR									
	SR									
	TR									
	UR									
	VR									
	WR									
	XR									

## **OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)**

	YR	Joseph P. Kirk, "Scattered Light in Photolithographic Lenses", Optical/Laser Microlithography VII (1994), SPIE Vol. 2197, pgs. 566-572			
	ZR				
	AAR				
	BBR				

Examiner

Date Considered:

\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.